

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	262	(rotat\$3 near imag\$3) same wafer	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/01/30 19:36
L2	5705	(382/141,144,145,147,148,152,286,289,291,292,298,299,149,151). CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/01/30 19:37
L3	11468	(356/399-401,614-616,624,630-632,445-448,237.1-237.6,238.1,238.3). CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/01/30 19:40
L4	1149	(250/559.01,559.29,559.3).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/01/30 19:41
L5	2185	(702/94,95,150-153,38).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/01/30 19:41
L6	7314	(355/53,55,77).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/01/30 19:41
L7	8086	(430/5,22,30).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/01/30 19:41
L8	436	(269/329,63,4).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/01/30 19:41
L9	555	(348/88,92,82,95).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/01/30 19:41
L10	1128	(700/114,186,192-194,257).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/01/30 19:42
L11	935	(414/935,936).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/01/30 19:42
L12	421	(345/649,672).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/01/30 19:42
L13	554	(2 3 4 5 6 7 8 9 10 11 12) and ("200612"\$2.pd. "2007"\$4.pd.)	US-PGPUB; USPAT; USOCR	OR	OFF	2007/01/30 19:43
L14	15	13 and ((prealign\$4 pre\$1align\$4) same (wafer semiconduct\$3))	US-PGPUB; USPAT; USOCR	OR	OFF	2007/01/30 19:43

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L15	15	13 and ((prealign\$4 pre\$1align\$4) same (wafer semiconduct\$3))	US-PGPUB; USPAT; USOCR	OR	ON	2007/01/30 19:44
L16	4	13 and (((edge notch) near detect\$3) same (wafer semiconduct\$3))	US-PGPUB; USPAT; USOCR	OR	ON	2007/01/30 19:46
L17	98	13 and ((rotat\$4 rotation\$4) same imag\$3)	US-PGPUB; USPAT; USOCR	OR	ON	2007/01/30 19:46
L18	18	13 and ((rotat\$4 rotation\$4) near imag\$3)	US-PGPUB; USPAT; USOCR	OR	ON	2007/01/30 19:49
L19	577	((prealign\$ pre\$1align\$4) same (wafer semiconduct\$3))	FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/01/30 19:49
L20	440	((edge notch) near detect\$3) same (wafer semiconduct\$3)	FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/01/30 19:50
L21	1000	19 20	FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/01/30 19:50
L22	301	21 and ((wafer semiconduct\$3) same (rotat\$4 rotation\$4))	FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/01/30 19:50